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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q81014

Shuho MOTOMURA

Appln. No.: 10/820,791

Group Art Unit: 1762

Confirmation No.: 8726

Examiner: Katherine A. BAREFORD

Filed: April 9, 2004

For: RESIST FILM FORMING METHOD AND A PHOTOMASK MANUFACTURING METHOD

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of June 8, 2006 to October 8, 2006.

Please charge the statutory fee of \$120.00 to Deposit Account No. 19-4880. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Ellen R. Smith  
Registration No. 43,042

WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: October 4, 2006

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